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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No. 9025

Hideki MUNAKATA

Group Art Unit: 1762

Application No.: 09/926,173

Examiner: Markham, Wesley D.

Filed: September 18, 2001

Attorney Dkt. No.: 107242-00021

For: WAFER STORAGE CASE, PROCESS FOR PREVENTING DUST
GENERATION THEREOF AND WAFER STORING METHOD

**NOTICE OF APPEAL TO THE BOARD OF PATENT APPEALS
AND INTERFERENCES AND PETITION FOR EXTENSION OF TIME**

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: November 17, 2004

Sir:

Applicants hereby appeal to the Board of Patent Appeals and
Interferences from the Decision of the Primary Examiner dated July 20, 2004
finally rejecting claims 3-10 and 12.

A timely response to the final rejection has been filed.

The \$340.00 Appeal Fee is attached.

The shortened statutory period expiring on October 20, 2004, it is hereby
requested that the period for response be extended for one month. Also included
in our check is \$110.00 as payment of the fee for a one month extension of time
for filing this Notice of Appeal.

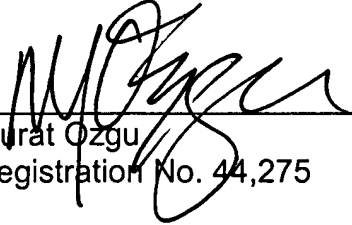
11/18/2004 YPOLITE1 00000009 09926173

01 FC:1401
02 FC:1251

340.00 OP
110.00 OP

Please charge any fee deficiency or credit any overpayment to our
Deposit Account No. 01-2300, referencing Docket No. 107242-00021.

Respectfully submitted,



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